

Notice of Allowability	Application No.	Applicant(s)
	10/620,666	HESS ET AL.
	Examiner	Art Unit
	Shamim Ahmed	1765
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to	olication. If not included will be mailed in due course. THIS
1. This communication is responsive to 7/12/05.		
2. ☑ The allowed claim(s) is/are <u>39-45</u> .		
<ol> <li>Acknowledgment is made of a claim for foreign priority una)</li></ol>	been received. been received in Application No	
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a reply ENT of this application.	complying with the requirements
4. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give		
5. CORRECTED DRAWINGS ( as "replacement sheets") must be submitted.		
(a) 🔲 including changes required by the Notice of Draftsperson's Patent Drawing Review ( PTO-948) attached		
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date		
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the C	ffice action of
identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the	84(c)) should be written on the drawing the header according to 37 CFR 1.121(c	igs in the front (not the back) of i).
<ol> <li>DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.</li> </ol>		
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Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5 Notice of Informal P	atent Application (PTO-152)
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☑ Interview Summary	'''''''''''''''''''''''''''''''''''''''
3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0	Paper No./Mail Dat	Paper No./Mail Date <u>9/27/05</u> .  7. ⊠ Examiner's Amendment/Comment
Paper No./Mail Date  4. Examiner's Comment Regarding Requirement for Deposit	8. 🛛 Examiner's Stateme	nt of Reasons for Allowance
of Biological Material	9.	Shamim Ahmed Primary Examiner Art Unit: 1765
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## **EXAMINER'S AMENDMENT**

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Tod. A. Myrum on 9/27/05.

The application has been amended as follows:

IN THE SPECIFICATION:

At page 1, paragraph 0001, line 2, after the phrase "October 16, 2001," insert "abandoned,"

IN THE CLAIMS:

Cancel the non-elected claims 1-18 and also cancel claims 35-38.

Claim 39 is amended as follows:

39. (Currently amended) A method of manufacturing a print head forming a cavitation layer of a print head comprising:

forming a first dielectric layer overlying at least a first portion of a substrate using atomic layer deposition;

forming a second dielectric layer having a first portion overlying at least a second portion of the substrate and a second portion, different from the first portion, overlying at least a portion of the first dielectric layer;

forming a cavitation layer overlying the first dielectric layer and in lateral contact with the first portion of the second dielectric layer using atomic layer deposition; and

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forming a third dielectric layer only on the second portion of the second dielectric layer using atomic layer deposition, and not on the cavitation layer.

- 2. The following is an examiner's statement of reasons for allowance: The prior art does not teach a process of forming a cavitation layer of a print head including the steps of forming a cavitation layer overlying the first dielectric layer and in lateral contact with the first portion of the second dielectric layer using atomic layer deposition and then forming a third dielectric layer only on the second portion of the second dielectric layer as the context of claim 39.
- 3. The closest prior art Hawkins (4,532,530) teaches a method of fabrication a printing head or fluid ejecting device, wherein a tantalum layer (46) is deposited as a protection layer, which resembles the claimed cavitation layer (col.5, lines 34-37 and figure 4A) but fails to teach forming a cavitation layer, which is in lateral contact with the first portion of the second dielectric layer and then forming a third dielectric layer only on the second portion of the second dielectric layer as the context of claim 39.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Shamim Ahmed whose telephone number is (571) 272-1457. The examiner can normally be reached on M-Thu (7:00-5:30) Every Friday Off.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine G. Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Shamim Ahmed Primary Examiner Art Unit 1765

SA September 27, 2005